

PATENT APPLICATION

**RESPONSE UNDER 37 CFR §1.116
EXPEDITED PROCEDURE
TECHNOLOGY CENTER ART UNIT 2814**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Hiroshi ISHIYAMA

Group Art Unit: 2814

Application No.: 10/778,029

Examiner: G. PERALTA

Filed: February 17, 2004

Docket No.: 118695

For: SEMICONDUCTOR MODULE HAVING INNER PRESSURE RELEASE PORTION

AMENDMENT AFTER FINAL REJECTION UNDER 37 CFR §1.116

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Interced w/ KCE
(UMB)
6/1/04

Sir:

In reply to the November 15, 2005 Office Action, please consider the following:

Amendments to the Claims as reflected in the listing of claims; and

Remarks.